

02-18-1999

ET

IBM Docket No.: HQ9-98-091

ad original documents or copy thereof.



To the Honorable Commissioner of Pa

1. Name of conveying party(ies):

100966490

address of receiving party(ies):

Farid Agahi Gary Bronner  
Herbert Ho Radhika Srinivasan

Additional name(s) of conveying party(ies) attached?

☐ Yes ☒ No

3. Nature of Conveyance:

☒ Assignment ☐ Merger  
☐ Security Agreement ☐ Change of Name  
☐ Other

Execution Date: 1/12/99, 1/12/99, 1/14/99, 1/20/99

Name: International Business Machines Corporation

Internal Address: N/A

Street Address: New Orchard Road

City: Armonk State: New York

Zip Code: 10504

Additional Name(s) &amp; Address(es) attached?

☐ Yes ☒ No

4. Application number(s) or patent number(s):

Title of Application: "SHALLOW TRENCH ISOLATION (STI) WITH BILAYER OF OXIDE-NITRIDE FOR VLSI APPLICATIONS"

If this document is being filed together with a new application, the execution date of the application is: 1/12; 1/12; 1/14; 1/20, 1999.

A. Patent Application No.(s)

B. Patent No.(s)

09/245,958

Additional numbers attached? ☐ Yes ☒ No

5. Name and address of party whom correspondence concerning document should be mailed:

Name: DeLIO & PETERSON, LLC  
Street Address: 121 Whitney Avenue  
City: New Haven State: CT  
Zip Code: 06510-1241

6. Total number of applications and patents involved:.....[ 1 ]

7. Total Fee (37 CFR 3.41) \$40.00  
☐ Enclosed  
☒ Authorized to be charged to Deposit Account number below  
☒ Any deficiencies in the enclosed fees

8. Assignee IBM Corporation Deposit Account Number:

09-0458

## CERTIFICATE OF MAILING UNDER 37 CFR 1.10

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on February 5, 1999  
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Signature

Date: February 5, 1999

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9. Statement and Signature.

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

H. Daniel Schnurmann

Name of Person Signing

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Total number of pages including cover sheet, attachments, and document: [ 5 ]

Signature

Date

Phone No.: 914-894-2481

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FI-069

PATENT

REEL: 9757 FRAME: 0007

## ASSIGNMENT

Whereas, we

Inventor and  
City(1) **FARID AGAHI**  
County of **TRAVIS**City of **AUSTIN**  
and State of **TEXAS**

and

(2) **GARY BRONNER**  
County Of **DUTCHESS**City Of **STORMVILLE**  
and State of **NEW YORK**

and

(3) **HERBERT HO**  
County of **ORANGE**City of **NEW WINDSOR**  
and State of **NEW YORK**

and

(4) **RADHIKA SRINIVASAN**  
County of **BERGEN**City of **MAHWAH**  
and State of **NEW JERSEY**

Title

have invented certain improvements in  
"SHALLOW TRENCH ISOLATION (STI)  
WITH BILAYER OF OXIDE-NITRIDE FOR  
VLSI APPLICATIONS"Date That  
Inventors  
Signed the  
Declarationand have executed, respectively, a United States patent application therefor  
on(1) *Farid Agahi*, 1999, and (2) \_\_\_\_\_, 19\_\_\_\_,  
and (3) \_\_\_\_\_, 19\_\_\_\_, and (4) \_\_\_\_\_, 19\_\_\_\_.

Whereas, INTERNATIONAL BUSINESS MACHINES CORPORATION, a corporation of New York, having a place of business at Armonk, New York 10504, (hereinafter called IBM), desires to acquire the entire right, title and interest in the said application and invention, and to any United States and foreign patents to be obtained therefor;

Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, we the above named hereby sell, assign, and transfer to IBM, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the invention set forth in said application to IBM, its successors and assigns; and we hereby agree that IBM may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by IBM.

TITLE: "SHALLOW TRENCH ISOLATION (STI) WITH BILAYER OF OXIDE-NITRIDE FOR VLSI APPLICATIONS"

City (1) Signed at Austin, Texas  
City State

Date on 1 / 12, 19 99

*Farid Agahi* signature  
**FARID AGAHI**

City (2) Signed at East Fishkill New York  
City State

Date on \_\_\_\_\_, 19\_\_\_\_ signature  
**GARY BRONNER**

(3) Signed at East Fishkill New York  
City State

Date on \_\_\_\_\_, 19\_\_\_\_ signature  
**HERBERT HO**

City (4) Signed at East Fishkill New York  
City State

Date on \_\_\_\_\_, 19\_\_\_\_ signature  
**RADHIKA SRINIVASAN**

ibm100214000asg1

## ASSIGNMENT

Whereas, we

Inventor and  
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County of **TRAVIS**City of **AUSTIN**  
and State of **TEXAS**

and

(2) **GARY BRONNER**  
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Title

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Inventors  
Signed the  
Declarationand have executed, respectively, a United States patent application therefor  
on(1) \_\_\_\_\_, 19\_\_\_\_, and (2) January 12, 1999,  
and (3) January 14, 1999, and (4) January 20, 1999.

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Now therefore, for a valuable consideration, receipt whereof is hereby acknowledged, we the above named hereby sell, assign, and transfer to IBM, its successors and assigns, the entire right, title and interest in the said application and invention therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the invention set forth in said application to IBM, its successors and assigns; and we hereby agree that IBM may apply for foreign Letters Patent on said invention and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by IBM.

TITLE: "SHALLOW TRENCH ISOLATION (STI) WITH BILAYER OF OXIDE-NITRIDE FOR VLSI APPLICATIONS"

City (1) Signed at Austin Texas  
City State

Date on \_\_\_\_\_, 19 99 \_\_\_\_\_ signature  
**FARID AGAHI**

City (2) Signed at East Fishkill New York  
City State

Date on Jan 12, 19 99 \_\_\_\_\_ signature  
**GARY BRONNER**

(3) Signed at East Fishkill New York  
City State

Date on Jan 14, 19 99 \_\_\_\_\_ signature  
**HERBERT HO**

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Date on Jan 20, 19 99 \_\_\_\_\_ signature  
**RADHIKA SRINIVASAN**

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